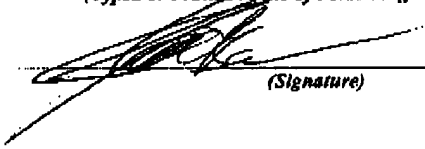


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No.
Applicant(s): WENBING YUN			LBL-IB-1498
Serial No. 09/927,428	Filing Date 08/09/2001	Examiner DEO, DUY VU NGUYEN	Group Art Unit 1765
Invention: METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES			
<p>I hereby certify that this <u>AMENDMENT (PAGES 1-30)</u> (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9216)</p> <p>on <u>20 JUNE 2003</u> (Date)</p> <p><u>JOHN P. O'BANION</u> (Typed or Printed Name of Person Signing Certificate)</p> <p> (Signature)</p> <p>Note: Each paper must have its own certificate of mailing.</p>			

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: WENBING YUN; ET AL.  
Serial No.: 09/927,428  
Filed: 08/09/2001  
For: METHOD FOR NANOMACHINING HIGH ASPECT RATIO  
STRUCTURES  
Group No.: 1765  
Examiner: DEO, DUY VU NGUYEN  
Docket No.: LBL-IB-1498

**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22213-1450**

**AMENDMENT**

Dear Sir:

In response to the Office Action mailed on February 20, 2003, please  
amend the above-identified U.S. patent application as follows:

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S/N 09/927,428

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